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\*\* CONTINUING DATA \*\*\*\*\* YES LV PCT US 05/07876

\*\* FOREIGN APPLICATIONS \*\*\*\*\* NONE LV

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY CA	SHEETS DRAWING 13	TOTAL CLAIMS 39	INDEPENDENT CLAIMS 2
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i> Initials LV				

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## TITLE

Methods for the optimization of substrate etching in a plasma processing system

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